

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s) : Keigo NAGAO, Tetsuro KUNISAWA, Tetsuo YAMADA  
Serial No. :  
For : **METHOD OF PRODUCING PIEZOELECTRIC THIN FILM  
DEVICE AND PIEZOELECTRIC THIN FILM DEVICE**  
Filed : herewith  
Int'l Appln. No. : PCT/JP2004/018890  
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745 Fifth Avenue  
New York, NY 10151

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Ronald R. Santucci

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**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

Preliminary to the examination of the above referenced patent application,

Applicants respectfully request that the application be amended as follows: